

EAST Search History

EAST Search History (Prior Art)

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L1	52	(substrate or base) same (photoresist or resist) same (patterned or patterning) same (separate or separated or separating or remove or removed or removing) and (microneedle or micro adj needle or microneedles or micro adj needles)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2010/02/25 20:00
L2	33	(substrate or base) same (photoresist or resist) same (patterned or patterning) same (separate or separated or separating or remove or removed or removing) near9 (photoresist or resist) and (microneedle or micro adj needle or microneedles or micro adj needles)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2010/02/25 20:01

L3	21	(substrate or base) same (photoresist or resist) same (patterned or patterning or processed or processing or etched or etching) same (microneedle or micro adj needle or microneedles or micro adj needles) and (separate or separated or separating or remove or removed or removing) near15 (patterned or processed or etched) near15 (photoresist or resist)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2010/02/25 20:07
----	----	---	--	----	-----	------------------

2/ 25/ 10 8:12:42 PM**C:\ Documents and Settings\ MVargot\ My Documents\ EAST\ Workspaces\ Default
EAST Workspace 1600x1200.wsp**